



1765

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: E. Morita

Serial No.: 09/726,860

Filed: November 30, 2000

For: METHOD OF MANUFACTURING  
CRYSTAL OF III-V COMPOUND OF THE  
NITRIDE SYSTEM, CRYSTAL  
SUBSTRATE OF III-V COMPOUND OF  
THE NITRIDE SYSTEM, CRYSTAL FILM  
OF III-V COMPOUND OF THE NITRIDE  
SYSTEM, AND METHOD OF  
MANUFACTURING DEVICE

Case No.: 9792909-4715

Examiner: M. Anderson

Group Art Unit: 1765

**Certificate of Mailing (37 CFR 1.8(a))**

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Dawn'te Norsweather 10/25/02  
Dawn'te Norsweather Date

TRANSMITTAL LETTER

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

Enclosed herewith is a Response C to First Non-Final Office Action in the  
above-identified patent application.

Also enclosed are: Request for Extension of Time  
Return Receipt Postcard

The Commissioner is hereby authorized to charge any additional fees  
required, as well as any patent application processing fees associated with this  
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No. 19-3140. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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